

Workshop on Advanced Techniques for Scientific Programming and Management of Open Source Software Packages (10-21 March), followed by LAMMPS Users and Developers Workshop and Symposium (24-28 March) | (smr 2574)

Contribution ID : **97**

Type : **not specified**

Atomistic simulation of polishing and grinding with multiple abrasive particles

Friday, 28 March 2014 10:15 (0:20)

Content

Summary

Primary author(s) : STEFAN EDER (AC2T Research Gmbh)

Presenter(s) : STEFAN EDER (AC2T Research Gmbh)

Session Classification : not yet classified